

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of :
Shin-Sang LEE :
Serial No. [NEW] :
Filed: September 5, 2003 :
For: PLASMA ETCHING APPARATUS :

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Application**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application, please
amend the above-identified application as follows:

Amendments to the Specification are reflected in the listing of claims which
begins of page 2 of this paper.

Remarks begin on page 3 of this paper.